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Ionization by bulk heating of electrons in capacitive radio frequency atmospheric pressure microplasmas

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Abstract

Electron heating and ionization dynamics in capacitively coupled radio frequency (RF) atmospheric pressure microplasmas operated in helium are investigated by particle-in-cell simulations and semi-analytical modeling. A strong heating of electrons and ionization in the plasma bulk due to high bulk electric fields are observed at distinct times within the RF period. Based on the model the electric field is identified to be a drift field caused by a low electrical conductivity due to the high electron–neutral collision frequency at atmospheric pressure. Thus, the ionization is mainly caused by ohmic heating in this ‘$\Omega$-mode’. The phase of strongest bulk electric field and ionization is affected by the driving voltage amplitude. At high amplitudes, the plasma density is high, so that the sheath impedance is comparable to the bulk resistance. Thus, voltage and current are about 45$^\circ$ out of phase and maximum ionization is observed during sheath expansion with local maxima at the sheath edges. At low driving voltages, the plasma density is low and the discharge becomes more resistive, resulting in a smaller phase shift of about 4$. Thus, maximum ionization occurs later within the RF period with a maximum at the discharge center. Significant analogies to electronegative low-pressure macroscopic discharges operated in the drift-ambipolar mode are found, where similar mechanisms induced by a high electronegativity instead of a high collision frequency have been identified.

(Some figures may appear in colour only in the online journal)

1. Introduction

Microscopic capacitively coupled plasmas operated at atmospheric pressure and at a radio frequency (RF) of typically 13.56 MHz, e.g. microscopic atmospheric pressure plasma jets (µ-APPJ), are frequently used for surface processing and medical applications [1–5]. The non-thermal glow discharge plasma in these sources consists of hot electrons and cold heavy particles (ions, neutrals) close to room temperature [6]. Such discharges can be used for sensitive surface treatments including human tissue. Atmospheric pressure plasmas avoid the necessity of expensive vacuum systems required for processing applications in low-pressure discharges, while providing a high degree of dissociation and an effective generation of reactive species useful for surface treatment [7–12].

There are different types of APPJs such as coaxial and plane parallel configurations [2, 5]. The latter design concept is based on the plasma jet introduced by Selwyn et al in 1998 [13] and modified by Schulz-von der Gathen et al [14]: the feed gas flows between two electrodes separated by a gap of about 1–2 mm and driven at 13.56 MHz. In the experiment...
the electrodes are typically made of stainless steel and are enclosed by quartz windows including the plasma volume and the effluent. In this way direct optical access to the plasma and the effluent is provided. Usually the discharge is operated in helium with some optional admixture of oxygen and/or nitrogen with typical gas velocities around 100 m s$^{-1}$ [15].

The generation of reactive species, that determine surface processes in the effluent, is caused by electron-impact excitation, ionization and dissociation in the plasma volume between the electrodes. Thus, a detailed understanding of the dynamics of highly energetic electrons in the plasma is essential and provides the basis for any optimization of surface processing applications. The electron dynamics in (microscopic) APPJs has been investigated experimentally by, e.g., Schulz-von der Gathen et al [14, 15], Benedikt et al [16], and Kong et al [17] by phase resolved optical emission spectroscopy [18] as well as numerically by Waskoenig et al [19] and Kong et al [20–22]. Within the RF period several maxima of the emission at distinct positions and times have been observed. (i) During shear expansion electrons are accelerated toward the opposing electrode and cause excitation/ionization adjacent to the expanding sheath edge [22]. (ii) At the time of maximum shear voltage excitation and ionization by secondary electrons are observed at both sheaths [19, 23, 24]. (iii) During shear collapse another excitation maximum is observed in microscopic APPJs at each electrode [17]. This maximum is assumed to be caused by an electric field reversal localized at the sheath edge and caused by electron–neutral collisions [25]. (iv) Significant excitation and ionization inside the bulk at the times of fastest shear expansion are observed [16, 17]. These maxima have been correlated with high bulk electric fields, but their exact physical origin is not completely understood. At low driving voltage or power, the excitation during shear expansion is typically stronger than the excitation by secondary electrons [17]. Such mode transitions induced by changing the RF voltage amplitude are similar to the mode transitions discussed by Belenguer and Boeuf at low pressures [26].

Here, we investigate the electron heating and ionization dynamics in an atmospheric pressure microplasma with plane parallel electrodes driven at 13.56 MHz, as a function of the RF voltage amplitude, by particle-in-cell (PIC) simulations and semi-analytical modeling. The discharge is operated in helium. We reveal the origin of the ionization in the bulk and show that the ionization maxima adjacent to the collapsing sheaths are not caused by a classical localized field reversal under the conditions investigated. Based on the analytical model, we demonstrate that the strong ionization in the bulk and at the sheath edges is caused by a high electric field inside the bulk at the time of maximum current. This high field originates from a low dc conductivity due to a high electron–neutral collision frequency at atmospheric pressure in the bulk. The phase shift between current and voltage is found to be affected by the driving voltage amplitude. Thus, maximum electron heating and ionization occur at different times within the RF period depending on the voltage amplitude, which also affects the spatial profile of the electron heating and ionization rates. We compare our results with low-pressure macroscopic electronegative capacitive discharges operated in CF$_4$, where similar effects are caused by the high electronegativity instead of a high collision frequency [27]. We conclude that a novel mode of discharge operation, the $\Omega$-mode, is present in atmospheric pressure microplasmas, where ionization is dominated by ohmic heating in the bulk.

The paper is structured as follows: in section 2, the PIC simulation and the semi-analytical model to describe the electric field in the bulk are introduced. In section 3, the results are presented and discussed. Conclusions are drawn in section 4.

2. Methods

2.1. PIC simulations

We use a 1d3v (one spatial dimension and three dimensions in velocity space) explicit kinetic code based on the PIC algorithm to study the heating and ionization dynamics in capacitive atmospheric pressure microplasmas with plane parallel electrodes of identical surface areas separated by a gap of 2 mm. Collisions are treated by the Monte Carlo method. The code works in the electrostatic approximation, i.e. $\dot{E} = -\nabla \phi$. The driving voltage waveform is $\phi = \phi_0 \cos(2\pi ft)$ with $f = 13.56$ MHz and an amplitude, $\phi_0$, between 330 V and 530 V. To overcome the limitation of a very small time step—the electron elastic collision frequency has to be resolved—the simulations are accelerated: we use a coarse-sorting algorithm for massive parallelization of the code on graphics processing units (GPU) [28]. We consider electrons and He$^+$ ions taking cross sections from [29, 30] and use an ion-induced secondary electron emission coefficient of $\gamma = 0.1$ as well as an electron sticking coefficient at the electrodes of 0.5. The gas temperature is set to 350 K.

In order to compare the results obtained for atmospheric pressure microplasmas operated in helium to low-pressure macroscopic electropositive and electronegative discharges we also perform PIC simulations of Ar and CF$_4$ discharges with an electrode gap of 1.5 cm operated at 80 Pa. The cross sections for Ar are taken from [30]. In the case of CF$_4$, we consider electrons and the ions CF$_3^+$, CF$_3^-$, F$^-$ using cross sections and rate coefficients from [31, 32]. A rate constant of $5.5 \times 10^{-13}$ m$^3$s$^{-1}$ is used for the ion–ion recombination (CF$_2^+$ + CF$_3^-$, CF$_3^+$ + F$^-$). The coefficient for secondary electron emission at the electrodes due to ion bombardment is varied in the electropositive case and is set to $\gamma = 0.1$ in electronegative CF$_4$. The probability of sticking of electrons at the electrodes is assumed to be 0.8 in these simulations. In both the electropositive and the electronegative cases at low pressure the gas temperature is kept constant at 350 K [33].

2.2. Semi-analytical model for the bulk electric field

In order to understand the physical origin of the bulk electric field obtained from the PIC simulations, an analytical expression for the electric field is deduced, following [25]. The model is based on a combination of the electron continuity and
momentum balance equations, i.e.:

$$\frac{\partial n_e}{\partial t} = -\frac{\partial \Gamma_e}{\partial x} + S_e,$$

(1)

$$\frac{\partial \Gamma_e}{\partial t} = -\frac{\partial (v_e \Gamma_e)}{\partial x} - \frac{1}{m_e} \frac{\partial p_e}{\partial x} - \frac{e}{m_e} n_e E - v_{ce} \Gamma_e.$$  

(2)

Here, \(p_e\) is the electron partial pressure, with \(p_e = k_B n_e T_e\), \(n_e\) is the electron density, \(T_e\) is the electron temperature, \(E\) is the electric field, \(\Gamma_e\) is the electron flux, \(m_e\) is the electron mass, \(S_e\) is the ionization source, and \(v_{ce}\) is the frequency of elastic electron–neutral collisions. Combining (1) and (2) and assuming quasi-neutrality in the bulk as well as a spatially homogeneous electron temperature yields:

$$E = \frac{m_e}{n_e e^2} \left( \frac{\partial j_e}{\partial t} + v_{ce} j_e + \frac{1}{e n_e^2} (j_e^2 - j_{he,e}^2) \frac{\partial n_e}{\partial x} + \frac{j_e S_e}{n_e} \right).$$  

(3)

Here, \(j_e = en_ce v_e\) is the electron conduction current density and \(j_{he,e} = en_ce \sqrt{k_B T_e} / m_e\). The first and third terms of equation (3) correspond to electric fields caused by inertia effects, while the second term is a drift field, the fourth term is the ambipolar (DA) mode, where ionization caused by strong electric fields inside the bulk at distinct times within the RF period dominates. These \(\gamma\)-electrons are accelerated and multiplied effectively inside the sheaths at the times of maximum sheath voltage, i.e. at about 3 and 40 ns (vertical dashed line in the second row [38, 39]).

Electronegative discharges can be operated in the drift-ambipolar (DA) mode, where ionization caused by strong electric fields inside the bulk at distinct times within the RF period dominates. This mode is observed in CF₄ discharges at 80 Pa such as shown in the third row of figure 1 [27].

In microscopic atmospheric pressure plasmas (figure 1), the electron density peaks in the central bulk region and decreases monotonically toward the electrodes similar to electropositive macroscopic CCRF discharges (first and second rows in figure 2). In contrast to low-pressure electropositive discharges the electric field is high inside the plasma bulk at two distinct times within the RF period.

3. Results

Figure 1 shows different plasma parameters resulting from PIC simulations of capacitively coupled microscopic atmospheric pressure plasmas operated in helium with an electrode gap of 2 mm at 13.56 MHz and a voltage amplitude of \(\phi_0 = 500 \text{ V}\). The spatio-temporal distributions of the electron density, space charge density, electric field, electron conduction current density, electron heating rate, and ionization rate obtained from the simulation are shown in plots (a)–(f), respectively. The electric field profile at the time of maximum ionization marked by vertical dashed lines in (a)–(f) resulting from the simulation and the individual terms of equation (3) is shown in plot (g). As the model is only valid in regions of quasi-neutrality, its results are not shown inside the sheaths. The first and third terms of equation (3) are added to limit the number of individual lines in the plot. Their sum and each individual value are close to zero everywhere in the discharge. The electron conduction current density at the discharge center and the applied driving voltage waveform are shown in plot (h).

Analogous simulation results for the spatio-temporal electron heating rate, ionization rate, electric field and electron density obtained in macroscopic low-pressure capacitively coupled RF (CCRF) discharges operated in argon and CF₄ at 13.56 MHz and 80 Pa with an electrode gap of 1.5 cm are shown in figure 2. The first row shows results for a discharge operated in argon at 80 Pa, 100 V voltage amplitude, and \(\gamma = 0\), the second row corresponds to an argon plasma at 80 Pa, 200 V and \(\gamma = 0.2\), and the third row shows results for CF₄ at 80 Pa, 400 V, \(\gamma = 0.1\). The rows of figure 2 correspond to the three different modes of electron heating known in macroscopic low-pressure capacitive RF plasmas: The first row corresponds to the \(\alpha\)-mode, where electrons are heated by direct interaction with the expanding sheaths and cooled by direct interaction with the collapsing sheaths [34–36]. This results in maximum ionization at distinct times within each RF period at about 26 and 63 ns. The first maximum is indicated by a vertical line in plots (a)–(d) in the first row of figure 2. If the second yield, \(\gamma\), is increased, the discharge is operated in \(\gamma\)-mode under otherwise similar conditions and the ionization is dominated by secondary electrons generated by ion impact at the electrodes. These \(\gamma\)-electrons are accelerated and multiplied effectively inside the sheaths at the times of maximum sheath voltage, i.e. at about 3 and 40 ns (vertical dashed line in the second row [38, 39]).
Figure 1. PIC simulation results (He, 1 atm, 13.56 MHz, 2 mm gap, 500 V): spatio-temporal plots of the (a) electron density, (b) space charge density, (c) electric field, (d) electron conduction current density, (e) electron heating and (f) ionization rate. Panel (g) shows the electric field profile at the time of maximum ionization (vertical dashed lines in (a)–(f)) and the individual terms of equation (3). Panel (h) shows the conduction current density at the discharge center and the applied voltage as a function of time.

Thus, the results of the model and the simulation show (figure 1(g)) that the high bulk field is predominantly a drift field caused by a low conductivity due to the high electron–neutral collision frequency at atmospheric pressure. This field increases slightly from the discharge center toward the sheaths due to the decreasing plasma density at constant conduction current density. Any slope of the electric field profile is correlated with a small local space charge shown in figure 1(b) [40]. Electrons are accelerated in this high bulk electric field and cause ionization, where the field is maximum, i.e. at the sheath edges. This also explains the local maximum of the ionization at the collapsing sheath edge, where no localized field reversal is present. Thus, the ohmic bulk heating of electrons in this $\Omega$-mode dominates the electron heating and
Figure 2. PIC simulation results: spatio-temporal plots of the electron heating rate (first column), ionization rate (second column), electric field (third column) and electron density (fourth column) in Ar and CF<sub>4</sub> discharges driven at 13.56 MHz and 80 Pa with an electrode gap of 1.5 cm. First row: Ar, 100 V, γ = 0. Second row: Ar, 200 V, γ = 0.2. Third row: CF<sub>4</sub>, 400 V, γ = 0.1. The color scales are given in units of 10<sup>5</sup> W m<sup>-3</sup> (heating rate), 10<sup>21</sup> m<sup>-3</sup> s<sup>-1</sup> (ionization rate), 10<sup>3</sup> V m<sup>-1</sup> (electric field) and 10<sup>15</sup> m<sup>-3</sup> (electron density). The vertical dashed lines indicate the time of maximum ionization. Reproduced from [27].

Figure 3. Profiles of (a) the electric field obtained from the simulation (black solid line) and (3) (dashed red line); (b) the second (drift field) and fourth (ambipolar field) terms of (3) in the bulk at t ≈ 26 ns (vertical dashed lines in figures 2(i)–(l)). Discharge conditions: CF<sub>4</sub>, 13.56 MHz, 400 V, 80 Pa, γ = 0.1. The vertical dashed lines indicate the time of maximum ionization. Reproduced from [27].

ionization dynamics under these conditions. A remarkable difference to the electron heating dynamics in low-pressure macroscopic CCRF discharges is the absence of electron cooling by the collapsing sheaths. This verifies the absence of direct interaction of electrons with the moving sheaths and the importance of the bulk heating.

Under the conditions investigated here, current and voltage are 46.8° out of phase due to the high plasma density, which causes the sheath impedance to be comparable to the bulk resistance, i.e. 1/(ω<sub>RF</sub>C<sub>s</sub>) ≈ R<sub>b</sub>. Here, ω<sub>RF</sub> = 2π · 13.56 MHz, C<sub>s</sub> ≈ ε<sub>0</sub>A/Î, is the effective capacitance of both sheaths determined from the time averaged sheath width, Î, and R<sub>b</sub> = (ν<sub>e</sub>d<sub>b</sub>)/(ω<sub>pe</sub>ε<sub>0</sub>A) is the bulk resistance determined from the bulk length, d<sub>b</sub>, and the electron plasma frequency, ω<sub>pe</sub> [37]. A is the electrode area.

The presence of a high bulk electric field in electropositive atmospheric pressure microdischarges is similar to the situation in low-pressure macroscopic and electronegative...
Figure 4. PIC simulation results (He, 1 atm, 13.56 MHz, 2 mm gap, 330 V): spatio-temporal plots of the (a) electron density, (b) space charge density, (c) electric field, (d) electron conduction current density, (e) electron heating and (f) ionization rate. (g) shows the electric field profile at the time of maximum ionization (vertical dashed lines in (a)–(f)) and the individual terms of equation (3). (h) shows the conduction current density at the discharge center and the applied voltage as a function of time.

CCRF discharges operated in the DA mode (third row in figure 2). Although these two types of capacitively coupled discharges differ significantly in pressure and charged particle species there is a low dc conductivity in the bulk, $\sigma_{dc} = \frac{e^2 n_e}{m_e \nu_{ce}}$, in both cases. However, the origin of the low conductivity is different. It can be explained by a high elastic collision frequency $\nu_{ce}$ in atmospheric pressure CCRF plasmas, while it is caused by a low electron density $n_e$ due to the high electronegativity in low-pressure macroscopic electronegative CCRF discharges [27]. In the latter case the second and fourth
terms of equation (3) reproduce the high bulk electric field such as shown in figure 3. The shape of the ambipolar field is caused by the presence of local maxima of the electron density in the electronegative edge regions of this electronegative plasma (figure 2(l)).

Decreasing the driving voltage amplitude from 500 to 330 V in the case of atmospheric pressure microdischarges operated in helium under otherwise identical discharge conditions as shown in figure 1 significantly affects the electron heating and ionization dynamics, as shown in figure 4. The electron density is approximately one order of magnitude lower (a) and the electric field (c), the electron conduction current density (d), the electron heating rate (e), and the ionization rate (f) are maximum in the bulk at a later phase within the RF period. This is caused by a higher bulk resistance due to the lower plasma density, which now dominates compared with the sheath impedance and reduces the phase shift between current and voltage to 3.6°, i.e. the discharge becomes more resistive [41, 42]. Since current and voltage are almost in phase, maximum bulk electric field, current, heating and ionization are observed at a later phase within the RF period. The electron heating is again dominated by ohmic bulk heating. The heating and ionization rates peak at the discharge center and no longer at the sheath edges, since the conduction current is only high in the centre. The high electric field at the center is still predominantly caused by a low dc conductivity due to the high collision frequency, i.e. the second term of equation (3). However, under these conditions there is a significant violation of quasineutrality, which increases toward the electrodes. As the applicability of the model is reduced in such regions, deviations between the modelled field and the electric field obtained from the simulation are found outside the center.

Figure 5 shows the phase shift between the applied voltage and the conduction current density at the discharge center, \( \Delta \theta_{V_I} \), as a function of the voltage amplitude between 330 and 530 V. The phase shift is found to increase monotonically due to the increasing plasma density and decreasing resistivity. At voltages above 530 V the PIC simulation diverges. This might correspond to arcing in the experiment.

4. Conclusions

Electron heating and ionization dynamics in capacitively coupled atmospheric pressure microplasmas operated in helium at 13.56 MHz and different voltage amplitudes were investigated by PIC simulations and semi-analytical modeling. The results were compared with electropositive argon and electronegative CF\(_4\) macroscopic low-pressure capacitive RF discharges. The electron heating dynamics in atmospheric pressure microplasmas is found to be dominated by the ohmic bulk heating of electrons due to high electric fields at the discharge center at the phases of maximum current in the RF period. The model reveals the physical origin of this \( \Omega \)-mode by identifying the high electric fields at the discharge center to be predominantly drift fields caused by a low conductivity due to the high electron–neutral collision frequency at atmospheric pressure. This heating mode is similar to the drift-ambipolar heating of electrons in low-pressure electronegative macroscopic capacitive discharges operated in CF\(_4\), where a high bulk electric field is caused by a low conductivity due to a low electron density resulting from the high electronegativity.

In atmospheric pressure microplasmas the heating and ionization dynamics are found to be affected by the amplitude of the driving voltage waveform. At high amplitudes, the plasma density is high and the bulk resistance is comparable to the sheath impedance, so that current and voltage are approximately 45° out of phase. Maximum ionization is observed adjacent to the sheath edges due to local maxima of the drift field caused by the ion density profile, that decreases toward the electrodes. These maxima of the ionization are not caused by direct interaction of electrons with the oscillating sheath electric fields such as observed in low-pressure macroscopic electropositive discharges. There is no cooling of electrons during sheath collapse. At lower driving voltage amplitudes, the plasma density decreases, so that the bulk resistance increases and the discharge becomes more resistive. Consequently, the phase shift between voltage and current decreases and maximum ionization is observed at the discharge center at a later phase within the RF period.

These results might improve the understanding of the spatio-temporal emission in microscopic APPJs [14–17] measured by phase resolved optical emission spectroscopy [18] and serve as a basis for a better understanding of chemical processes in such plasmas. Future investigations of the \( \Omega \)-mode in electronegative atmospheric pressure microplasmas as well as experimental verifications of the observed dependence of the phase shift between current and voltage on the driving voltage amplitude are clearly required.

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